


A	INITIAL RELEASE	ECE 12APR18
REV	DESCRIPTION	DATE

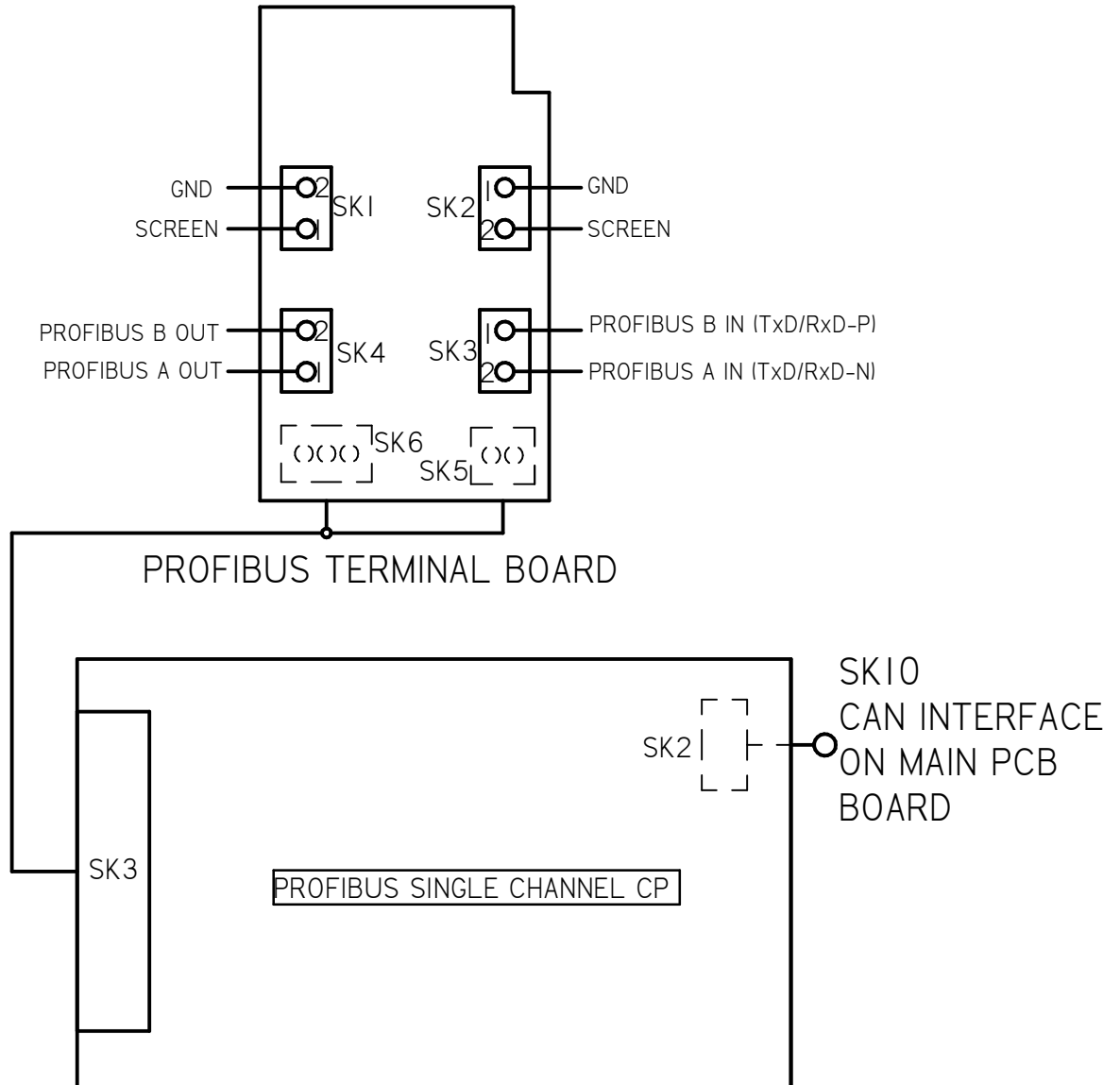
- NOTES:  
 1. 4-20 mA OUTPUT, 24VDC NOMINAL, (18-30 VDC MAXI)  
 2. SEE ADDITIONAL PAGES FOR COMMUNICATIONS WD IF ATTACHED


<b>TOLERANCES</b> UNLESS OTHERWISE SPECIFIED .XX = ±.02    XXX = ±.005    ANGULAR ±1°		
SCALE: NTS		
DRAWN: ECE	PROD. DV.	PROD. ENG.
DATE: 12APR18	DATE:	DATE:

  
 MILWAUKEE, WISCONSIN, USA

This print is the property of Rotork Process Controls and is loaned in confidence subject to return. All rights to design or invention are reserved.

TITLE : <b>CMA 1500 &amp; 3000          WIRING DIAGRAM</b>	
FOR : 24V DC POWER OPERATION LOCAL CONTROLS, RIRO, PROFIBUS	
SHT 1 OF 3	<b>M42-PD</b>



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ECE					<b>M42-PD</b>
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**RIRO REMOTE INPUTS - DEFAULT SETTINGS**

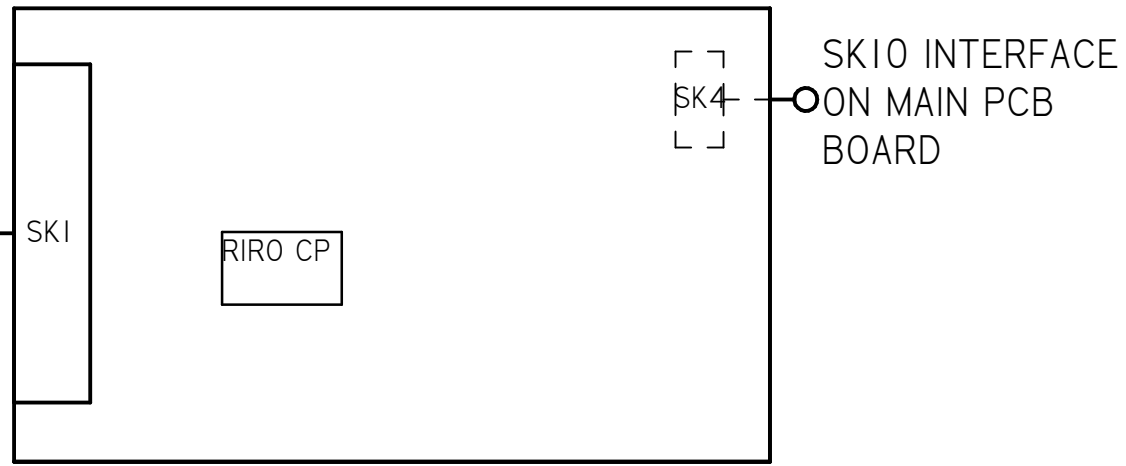
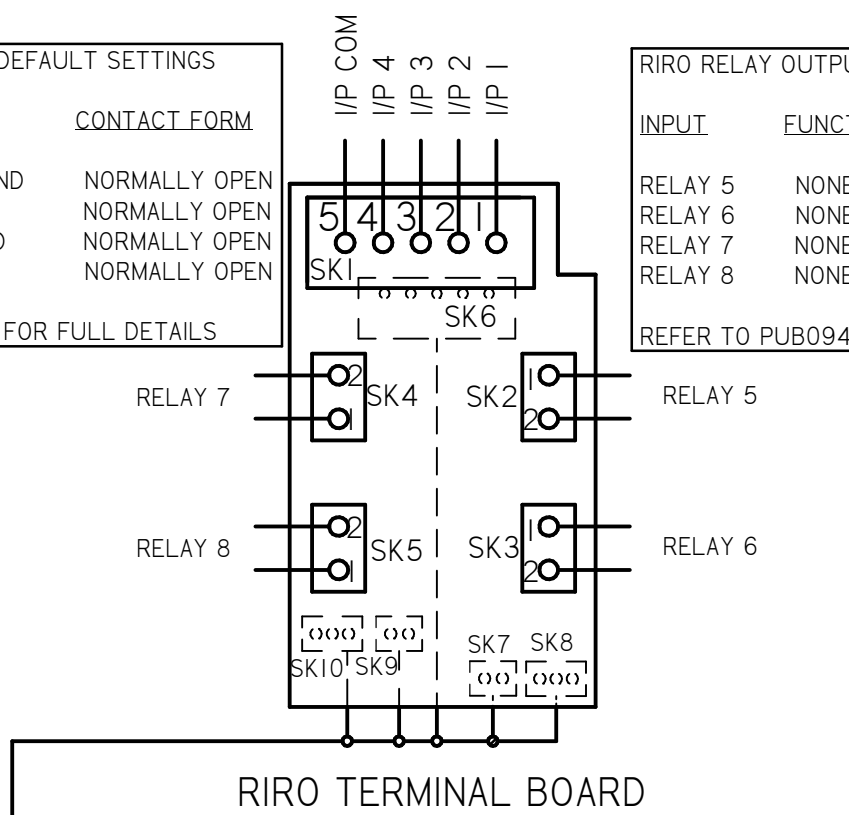
INPUT	FUNCTION	CONTACT FORM
I/P1	CLOSE COMMAND	NORMALLY OPEN
I/P2	STOP/MAINTAIN	NORMALLY OPEN
I/P3	OPEN COMMAND	NORMALLY OPEN
I/P4	ESD	NORMALLY OPEN

REFER TO PUB094-004 FOR FULL DETAILS

**RIRO RELAY OUTPUTS- DEFAULT SETTINGS**

INPUT	FUNCTION	CONTACT FORM
RELAY 5	NONE	ENERGIZE ON CONDITION
RELAY 6	NONE	ENERGIZE ON CONDITION
RELAY 7	NONE	ENERGIZE ON CONDITION
RELAY 8	NONE	ENERGIZE ON CONDITION

REFER TO PUB094-004 FOR FULL DETAILS



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